

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application of:)

Applicant(s): Yeshaiahu Fainman et al.)

Serial No.: 10/521,425)

Conf No.: 9057)

Filed: March 22, 2005)

For: HOLOGRAPHICALLY DEFINED...)

Art Unit 2814)

Examiner: Rao, Shrinivas H.)

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

9/7/07

Date

Attorney for Applicant(s)

Registration No. 43,874

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This IDS is submitted under 37 C.F.R. §1.97(c), after the C.F.R. §1.97(b) time period, but before the mail date of a Final Office Action or a Notice of Allowance (whichever occurs first), with either:

- (a) a statement under 37 C.F.R. §1.97(e); or
(b) the \$180.00 fee under 37 C.F.R. §1.17(p).

Applicant(s) submit herewith Form PTO-1449 (Information Disclosure Citation) together with copies of foreign patents, publications or other information of which applicant(s) are aware, which applicant(s) believe may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Applicant(s) respectfully submit that the citation of any reference on Form PTO-1449 does not constitute an admission that the reference qualifies as prior art.

It is requested that the information disclosed on the enclosed Form PTO-1449 be made of record in this application.

() Statement Under 37 C.F.R. §1.97(e):

() The enclosed references were cited in a Communication issued by the [Japanese, European, etc.] Patent Office (copy enclosed). Applicant(s) hereby certify that each item of information cited on the enclosed Form PTO-1449 was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

(X) Applicant(s) hereby certify that no item of information cited on the enclosed Form PTO-1449 was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing below after making reasonable inquiry, no item of information cited on the enclosed Form PTO-1449 was known to any individual designated in §1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

(X) Enclosed is a check for \$180.00 to cover the fee as set forth in 37 C.F.R. § 1.17(p).

The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or to credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

300 South Wacker Drive-Suite 2500
Chicago, Illinois 60606
Telephone: (312) 360-0080
Facsimile: (312) 360-9315
Customer Number 24978
P:\DOCS\0321\68095\BR9035.DOC

Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

By:

Arik B. Ranson, Registration No. 43,874

06/10/2007 RFEKRUJ 00000011 10521425 180.00 DP
01 FC:1806

AUG 09 2007

Sheet 1 of 1

Form PTO-1449 U.S. Department of Commerce
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 0321.68095

Serial No.: 10/521,425

Applicant: Yeshaiahu Fainman et al.

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Filing Date: March 22, 2005

Group: 2814

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclasses	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	M. CAMPBELL et al., "Fabrication of photonic crystals for the visible spectrum by holographic lithography," Letters to Nature, Vol. 404, March 2, 2000, pp. 53-56.
	S. SHOJI et al., "Photofabrication of three-dimensional photonic crystals by multibeam laser interference into a photopolymerizable resin," Applied Physics Letters, Vol. 76, No. 19, May 8, 2000, pp. 2668-2670.
	P. VISCONTI et al. "Nanopatterning of organic and inorganic materials by holographic lithography and plasma etching," Microelectronic Engineering, Vol. 53, 2000, pp. 391-394.

Examiner

Date Considered

*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.